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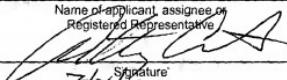
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

on July 31, 2003

Date of Deposit

Anthony P. Curtis, Ph.D., Reg. No. 46,193

Name of Applicant, assignee or  
Registered Representative



Signature

7/31/03

Date of Signature

Our Case No. 10125/4115

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Chae Gee Sung )  
Serial No. Not yet assigned )  
Filing Date: Herewith )  
For THIN FILM TRANSISTOR, )  
METHOD OF PRODUCING THE )  
SAME, LIQUID CRYSTAL )  
DISPLAY, AND THIN FILM )  
FORMING APPARATUS )

## PRELIMINARY AMENDMENT

Mail Stop PATENT APPLICATION  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Prior to examination of the above-identified application, please amend application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** begin on page 3 of this paper.

**Remarks** begin on page 5 of this paper.

**In the Specification:**

Before the first line of the specification please insert the following:

This application is a divisional of application number 10/020,610, filed December 7, 2001.